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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TECHNOLOGY CENTER 2800

Applicant(s): Richard D. Harris, et al.
Serial No.: 09/842,975
Filed: April 26, 2001
For: Method for Fabricating an Isolated Microelectromechanical System (MEMS) Device Incorporating a Wafer Level Cap
Group Art Unit: 2811
Docket No.: 110003.97397

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
Washington, D. C. 20231

Dear Sir:

In response to the Restriction Requirement dated August 23, 2002, please consider Applicant's response as follows:

REMARKS

The Restriction Requirement requires Applicant to elect either Group I (claims 1-24, 31-46) or Group 2, (claims 25-30).

I. Election

In response to the requirement, Applicant elects Group I, claims 1-24 and 31-46 without traverse.

II. Conclusion

The Examiner is invited to contact the undersigned at the telephone number appearing below if such would resolve any further issues regarding the Restriction Requirement.